

Docket No.: 12088/019001
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Shinichi Kawasaki et al.

Application No.: 10/500,317

Confirmation No.: 9863

Filed: June 28, 2004

Art Unit: 1792

For: PLASMA FILM FORMING SYSTEM

Examiner: R. Zervigon

REPLY UNDER 37 C.F.R. § 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Madam:

In response to the Office Action dated October 21, 2008, please reconsider this application in view of the following.